

FIG.1

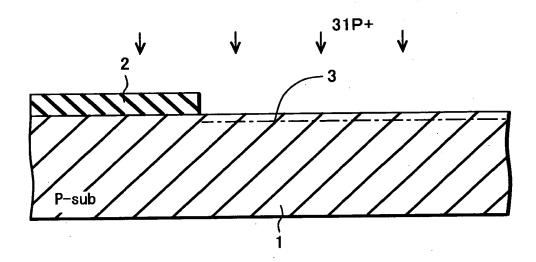
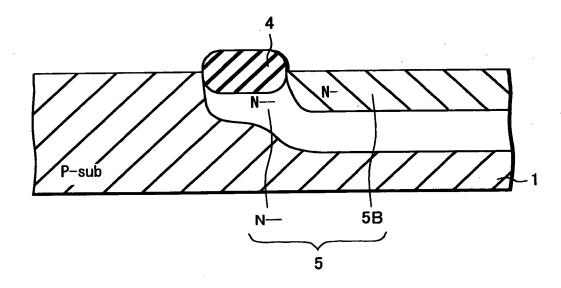


FIG.2



2/9

FIG.3

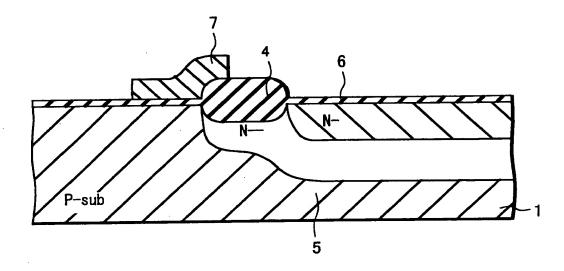


FIG.4

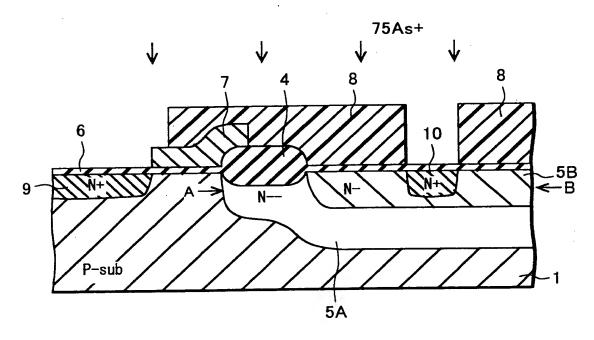


FIG.5

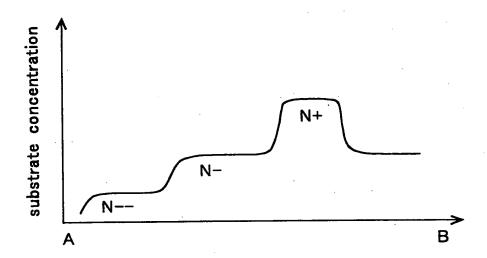


FIG.7

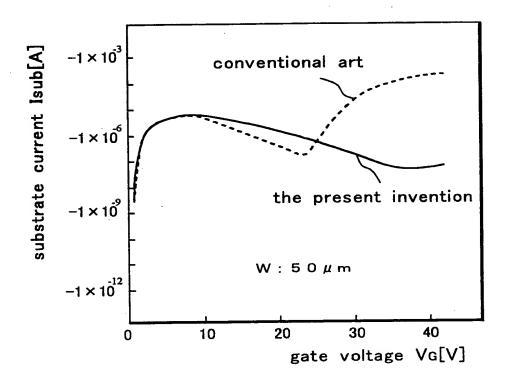
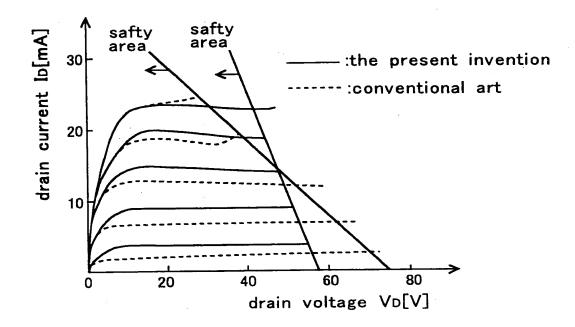


FIG.8



Applicant(s): Shuici Kikuchi et al.
SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME

FIG.9

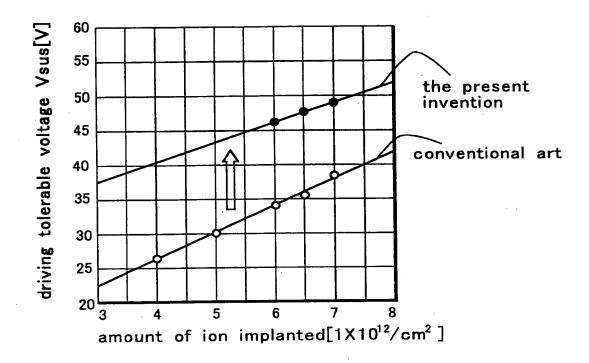


FIG.10

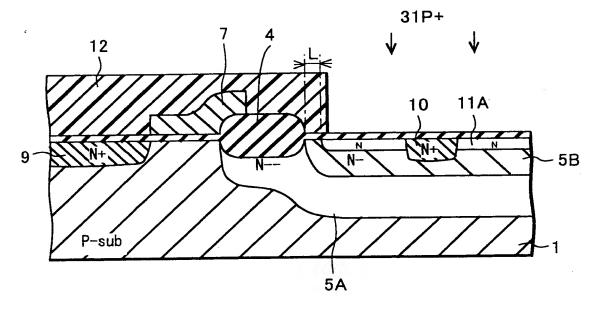


FIG.11

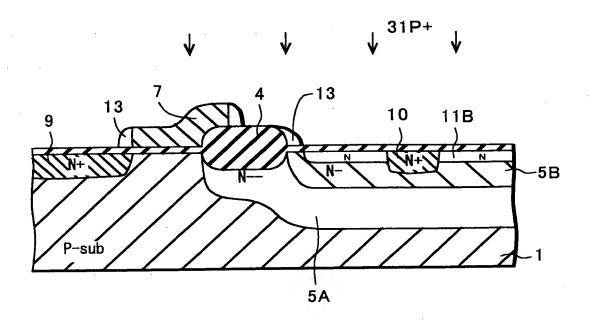
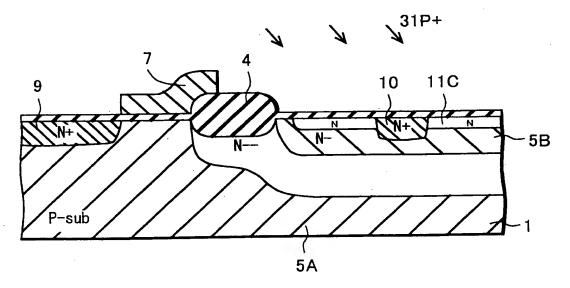


FIG.12



Page 8 of 9

Appln No.: 09/829,876 Applicant(s): Shuici Kikuchi et al. SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

8/9

FIG.13 (PRIOR ART)

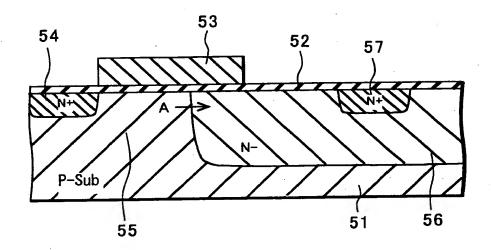
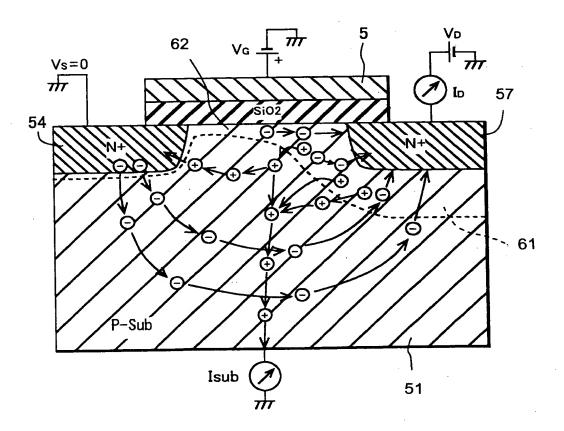


FIG.14 (PRIOR ART)



Page 9 of 9

Appln No.: 09/829,876

Applicant(s): Shuici Kikuchi et al. SEMICONDUCTOR DEVICE AND METHOD OF

MANUFACTURING THE SAME

9/9

FIG.15 (PRIOR ART)

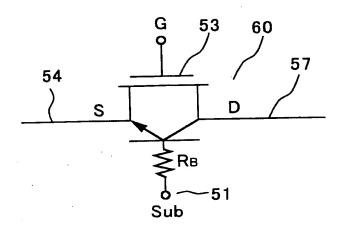


FIG.16 (PRIOR ART)

